

11/02/2005 10:40 FAX 440 248 3432

METAULLICS SYSTEMS

→ S MC COLLISTER 003

No. 4871 P. 3

Nov. 1, 2005 3:57PM Fay Sharpe



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT(S) : David Neff  
TITLE : BONDED PARTICLE FILTERS  
APPLICATION NO. : 10/659,817  
FILED : September 11, 2003  
CONFIRMATION NO. : 5262  
EXAMINER : Scott R. Kastler  
ART UNIT : 1742  
LAST OFFICE ACTION : September 29, 2005  
ATTORNEY DOCKET NO. : MLCZ 2 00106

**DECLARATION UNDER 37 CFR § 1.132**

*Do you know Dr. David Neff?*  
*Yes*  
*No*  
*Don't know*

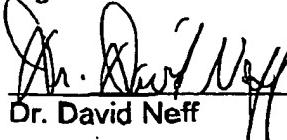
I am the inventor of the subject application.

I have worked in the field of molten metal processing for over 30 years.

I have discovered that providing a beveled end on a filter that mounts to a dosing tube results in a greatly increased efficacy for such a filter as compared to known filtering methods and apparatus. The beveled end allows for an increase in filtering surface area as compared to known filtering methods and apparatus.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both under 18 U.S.C. § 1001 and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Signed:

  
Dr. David Neff

Nov. 2, 2005  
Date